

Simulation studies of the technical prototype for the Mu3e Tile Detector

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on behalf of the Tile Detector group
Kirchhoff Institute for Physics

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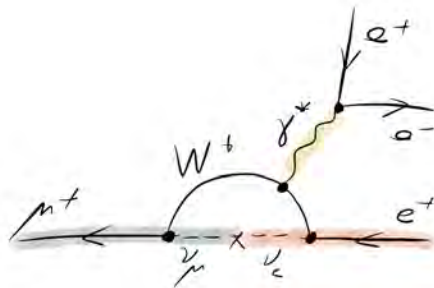


Kirchhoff-
Institut
für Physik



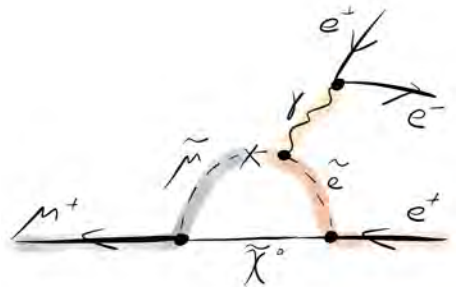
The decay $\mu \rightarrow eee$

- lepton flavour violating (LVF) decay
- Standard Model:
 - via neutrino oscillation
 - suppressed by more than $O(10^{-54})$



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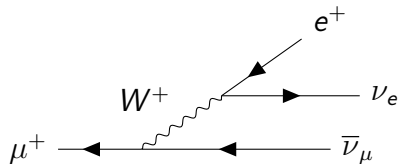
- **lepton flavour violating (LVF) decay**
- Standard Model:
 - via neutrino oscillation
 - suppressed by more than $O(10^{-54})$
- observation would be sign of new physics
- current limit: $BR < 10^{-12}$ by the SINDRUM experiment



two types of background sources:

1) internal conversion:

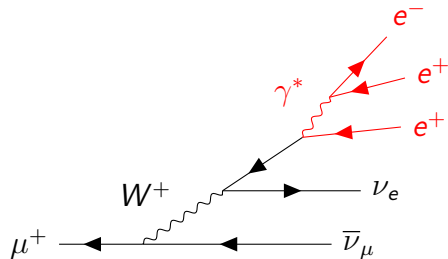
- $\mu \rightarrow eee\nu\nu$
- veto via reconstruction of missing neutrino energy
- excellent momentum resolution needed



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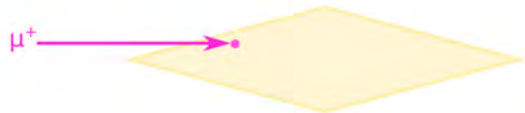
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2) accidental background:

- muon decay + electron-positron scattering
- veto via precise vertex and **time** determination

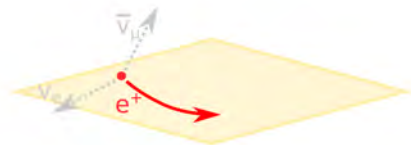


[scheme by Frank Meier Aeschbacher]

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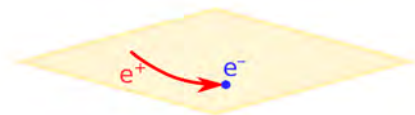


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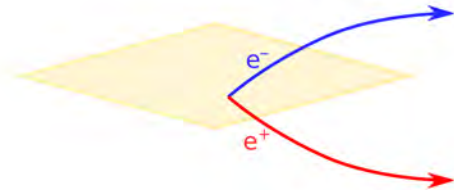


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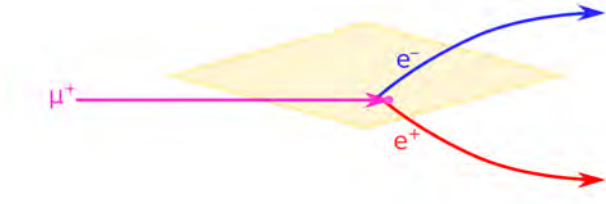


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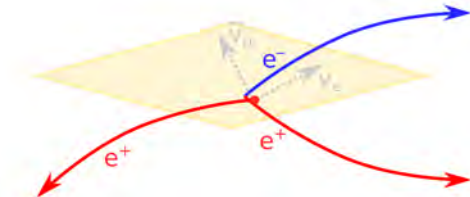


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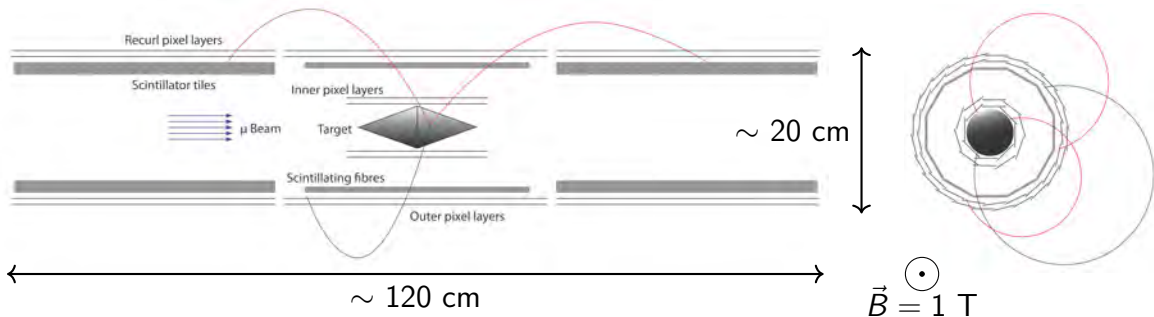
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[scheme by Frank Meier Aeschbacher]

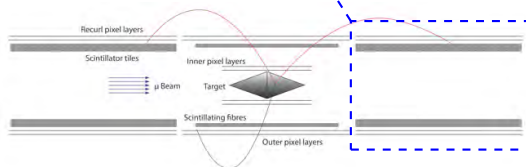
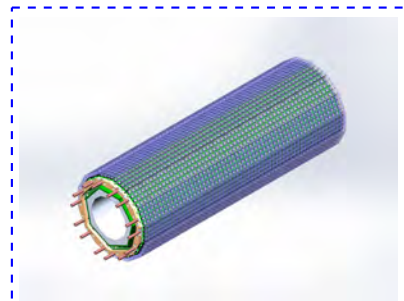
The Mu3e experiment

- target sensitivity $\leq O(10^{-16})$
 - pixel detectors: tracking, vertexing
 - scintillating fibre (SciFi) Detector and **Tile Detector: timing**
- fixed target experiment
 - to be installed at PSI, Switzerland



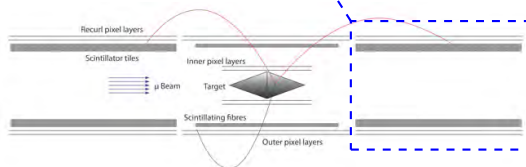
The Tile Detector

- to be installed on recurl stations (up- and downstream of target)
- **requirements:**
 - time resolution < **100 ps**
 - detection efficiency $\sim 100\%$
 - hit rate up to 60 kHz per channel
- scintillating tiles and silicon photomultipliers (SiPMs)



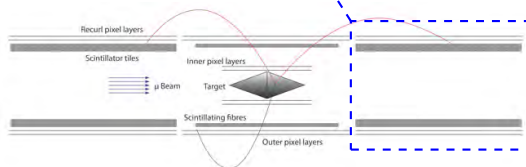
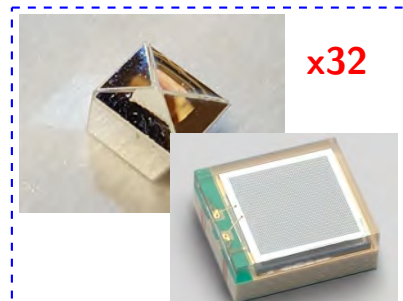
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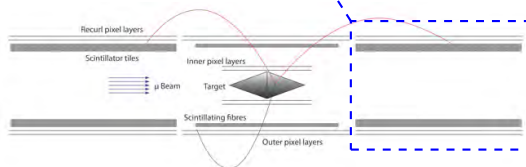
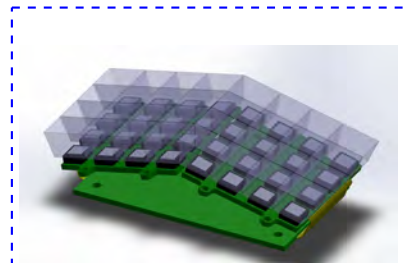
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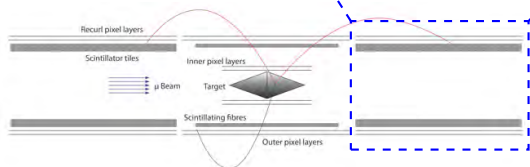
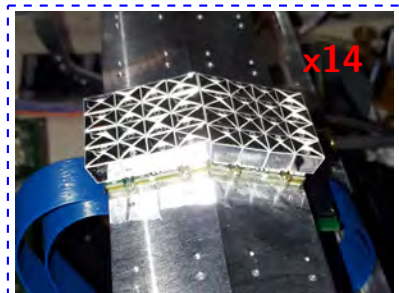
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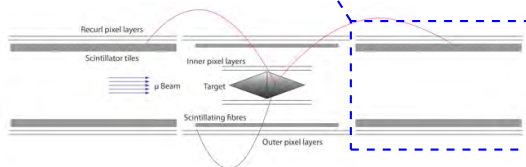
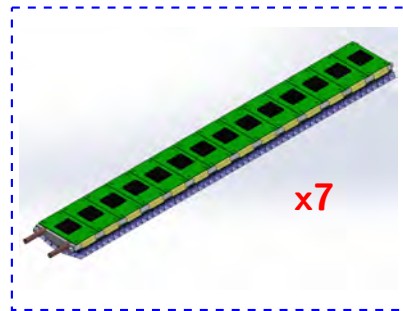
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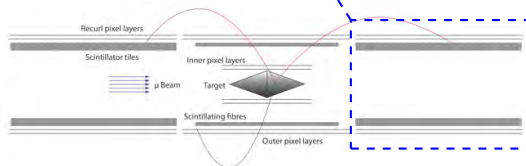
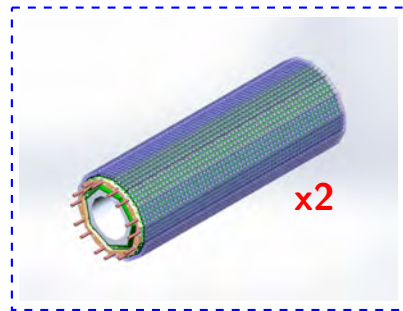
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- **reduction of accidental background by factor 100**



we want a **reliable thermal simulation** because:

- 1) Tile Detector surrounded by pixel detector
 - cooled with helium \Rightarrow heat gradient
 - SiPM operation? (\Rightarrow HV?)
- 2) integration of services (cooling pipes and ducts, cables, ...)
 - check different geometries of Tile Detector
 - test in simulations first

→ **full detector simulation important to finalise design!**

idea:

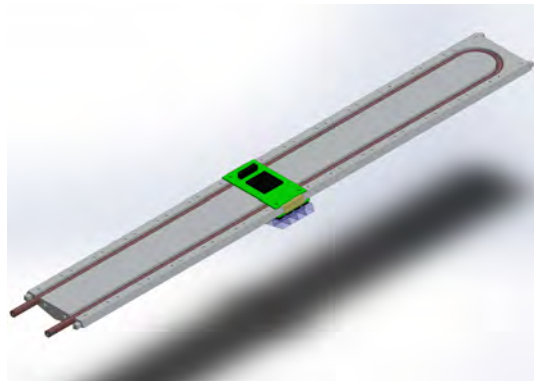
- build simple setup in the lab
- try to replicate as close as possible in simulation
 - geometry
 - material (heat transfer, coupling between materials,...)
 - environment
- **goal:** reliable simulation
 - can be extended/modified

Thermal simulation - setup and input

- thermal simulation using 3D CAD software SolidWorks
 - "Flow Simulation" add-in to model water and air flow
 - finite element method
 - takes care of material properties, heat exchange,...

- **ingredients:**

- cooling plate + pipe
- one submodule
- "box" of air → lab environment

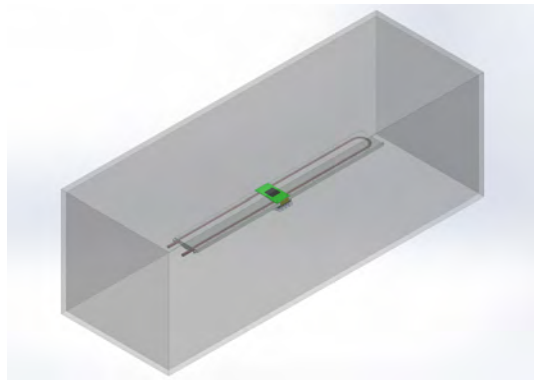


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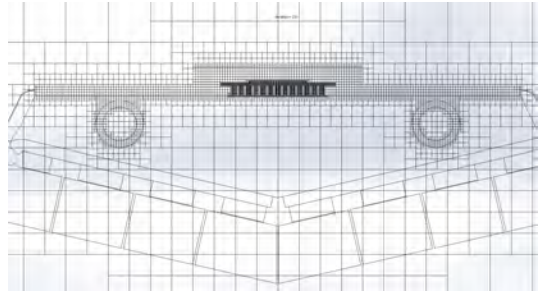
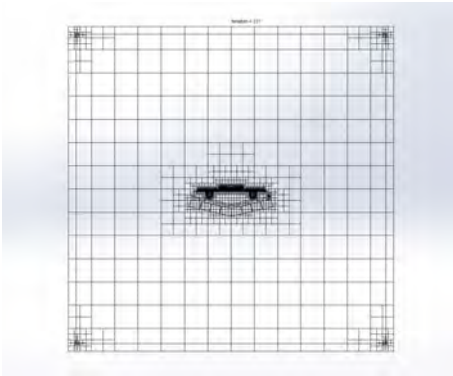
- **input from lab measurements:**

- water temperature: 15°C
- volume flow of water: 4.7 cm³/s
- environment temperature: 21°C
- different chip power consumptions:
 - ~ 2.1 W
 - ~ 1.7 W
 - ~ 0.86 W

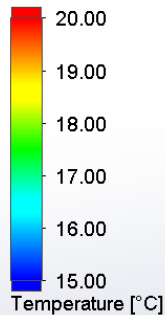
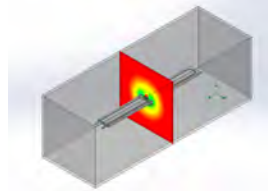
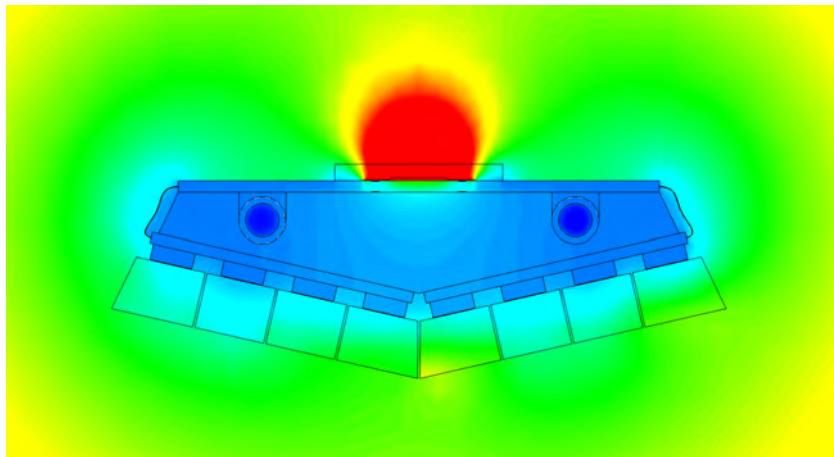
⇒ measurement of chip temperature

Meshing

- optimise mesh settings
 - too coarse: results unreliable
 - too fine: computing time and resources skyrocket!



Power consumption: ~ 2.1 W



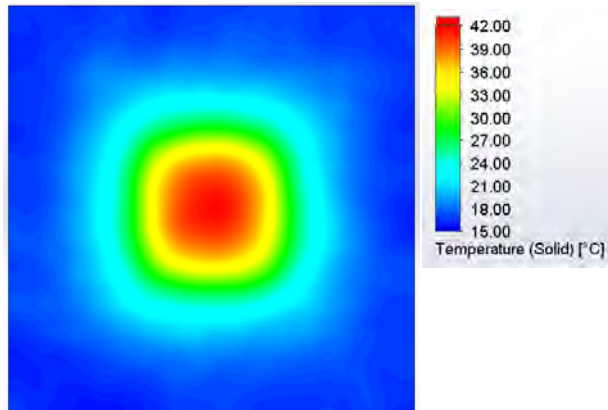
Temperature approximation

- temperature sensor: $\sim 4.5 \times 4.5 \text{ mm}^2$
- **simulation:** approximate using circle with $\varnothing = 4.5 \text{ mm}$
 - average over area

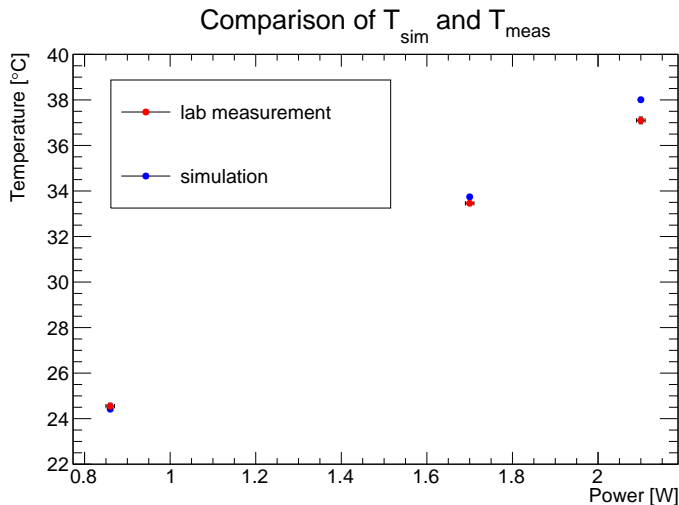
→ for $P_{\text{chip}} \approx 2.1 \text{ W}$: $T_{\text{top}}^{\text{sim}} \approx 38^\circ\text{C}$
 $T_{\text{top}}^{\text{meas}} \approx 37^\circ\text{C}$



package top:

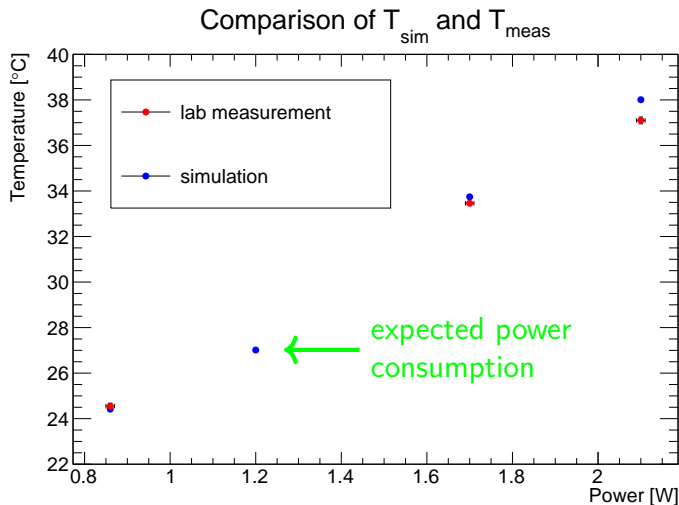


Comparison with lab measurements



→ very good agreement between data and simulation (difference $\leq 1^\circ\text{C}$)

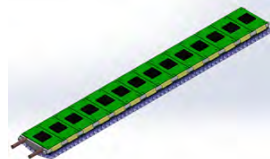
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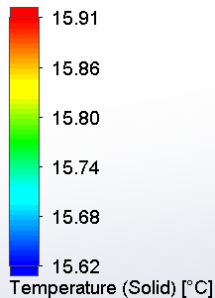
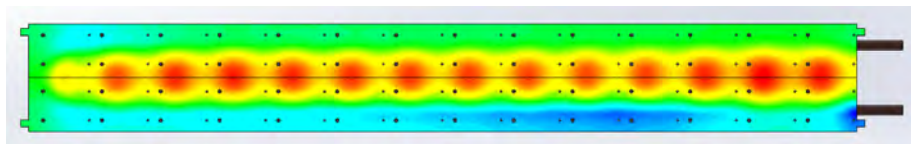
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Simulation of full module

in progress



bottom view of the **cooling plate** (SiPM/tile side):



$T_{\min} = 15.62^{\circ}\text{C}$, $T_{\max} = 15.91^{\circ}\text{C}$
→ small heat gradient

↑
water inlet

summary:

- thermal simulation is important to finalise detector design
- simulation of simple setup \leftrightarrow direct comparison to lab measurements
 - preliminary results look promising

next steps:

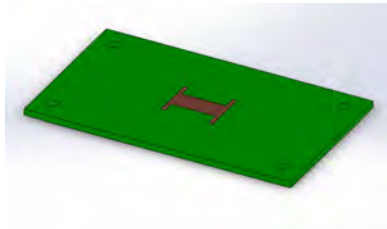
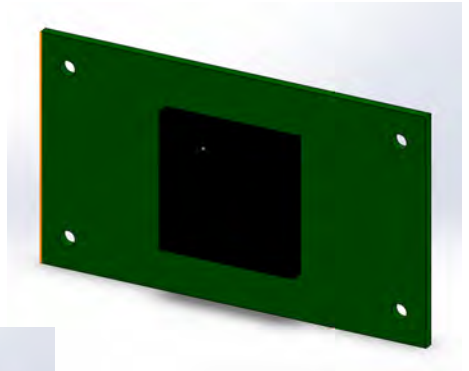
- full module simulation
- test changes in geometry
 - thinner cooling plate, smaller pipes, ...
- module surrounded by helium (gradient!)
 - **effect on SiPMs?**

Thank you for your attention!

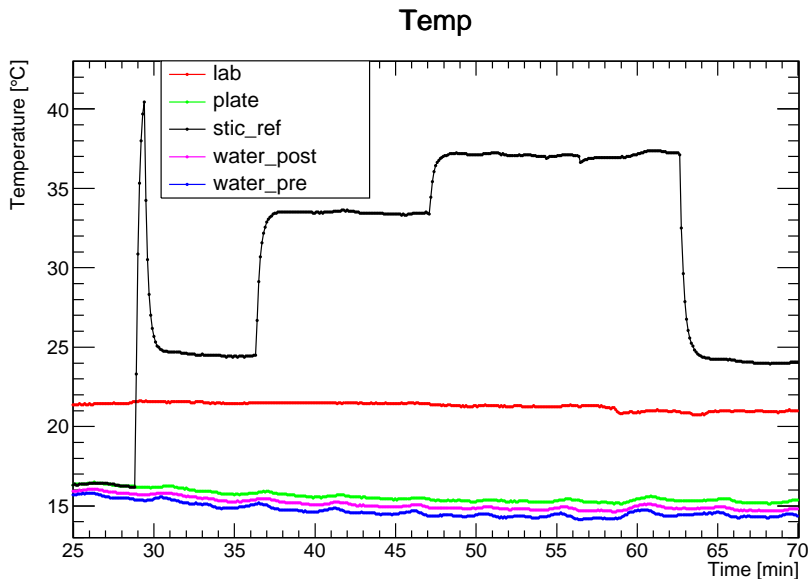
Appendix

Chip and PCB modelling

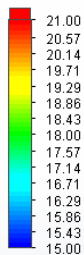
- ASIC in lab setup and simulation: **STiC V3**
 - predecessor of MuTRiG
- chip and package modelling
 - heat transfer defined "by hand"
(based on data from manufacturer)
- PCB modelling
 - thermal vias implemented in STiC PCB



Power consumption: ~ 2.1 W: flow speed

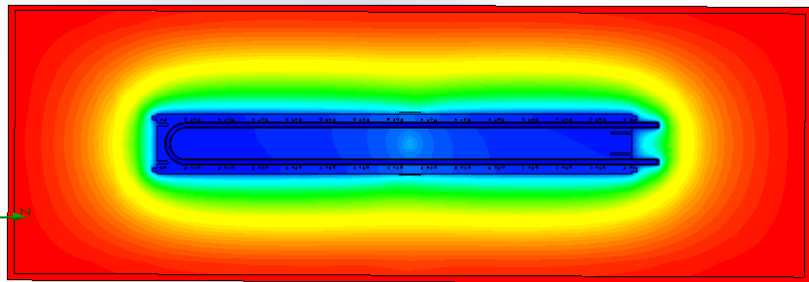


Power consumption: ~ 2.1 W: top view

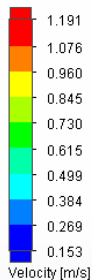


Temperature [°C]

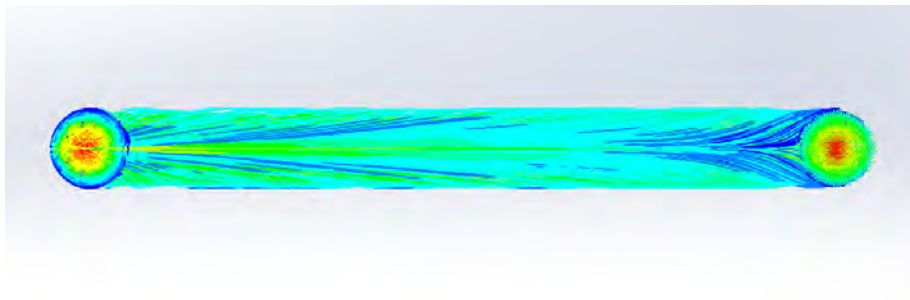
Cut Plot 2: contours



Power consumption: ~ 2.1 W: flow speed



Flow Trajectories 1



Full module

